

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jiang et al.
 Serial No.: 09/966,605
 Filing Date: 09/28/2001
 Customer No.: 23494

Art Unit: 1765
 Examiner: Vinh, Lan
 Docket No.: TI-31462
 Conf. No.: 4769

Title: IN-SITU PLASMA ASH/TREATMENT AFTER VIA ETCH OF LOW-K FILMS FOR POISON-FREE DUAL DAMASCENE TRENCH PATTERNING

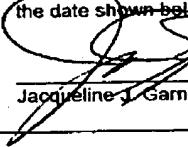
REQUEST FOR EXTENSION OF TIME

Commissioner of Patents
 PO Box 1450
 Alexandria, VA 22313-1450

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I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on the date shown below:


 Jacqueline J. Garner, Reg. No. 36,144

April 19, 2004
 Date

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner for an extension of the shortened statutory period for response in the above-identified Application.

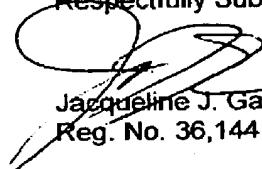
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One Month (\$110)
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Respectfully Submitted,

Texas Instruments Incorporated
 PO Box 655474, M/S 3999
 Dallas, TX 75265
 (214) 532-9348
 Fax: (972) 917-4418


 Jacqueline J. Garner
 Reg. No. 36,144

To: Technology Center 1700
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<input type="checkbox"/> DECLARATION (# Pages)	<input type="checkbox"/> NOTICE OF APPEAL (# Pages)
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<input type="checkbox"/> CONTINUATION APP'N (# Pages)	<input checked="" type="checkbox"/> RCE transmittal (1 page)
<input type="checkbox"/> DIVISIONAL APP'N	
NAME OF INVENTOR(S):	
Jiang et al	
TITLE OF INVENTION:	
In-Situ Plasma/Ash/Treatment ...	
TIFILE NO.:	DEPOSIT ACCT. NO.:
TI-31462	20-0668
FAXED: 4/19/2004	
DUE: 2/18/2004	
ATTY/SEC'Y: JJG	
RECEIPT DATE & SERIAL NO.:	
Serial No.: 09/966,605	
Filing Date: 09/28/2001	

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